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CONFIRMATION NO. 3409

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/586,953	07/25/2006	438	1792	128832	
RULE					
APPLICANTS Makoto Iida, Fukushima, JAPAN; Toshihiko Imai, Fukushima, JAPAN; Katsuichi Sato, Fukushima, JAPAN; Miho Iwabuchi, Fukushima, JAPAN; Masahiro Kato, Gunma, JAPAN;					
** CONTINUING DATA ***** This application is a 371 of PCT/JP05/00839 01/24/2005					
** FOREIGN APPLICATIONS ***** JAPAN 2004-025923 02/02/2004					
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/31/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /G. NAGESH NAGESH RAO/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 3	TOTAL CLAIMS 52	INDEPENDENT CLAIMS 9
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES					
TITLE Silicon single crystal, a silicon wafer, an apparatus for producing the same, and a method for producing the same					
FILING FEE RECEIVED 3700	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		